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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet **2**of **3****Complete if Known**

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| Application Number | 10/781,166 |
| Filing Date | February 18, 2004 |
| First Named Inventor | Richard W. Foote |
| Art Unit | 2829 |
| Examiner Name | Not Yet Assigned |
| Attorney Docket Number | P05810 |

| U. S. PATENT DOCUMENTS | | | | | |
|------------------------|-----------------------|--|--------------------------------|--|---|
| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
| | | Number-Kind Code ² (if known) | | | |
| TN ↓ | BA | US- 6,294,474 | 09/25/2001 | Tzeng et al. | |
| | BB | US- 6,307,213 | 10/23/2001 | Huang et al. | |
| | BC | US- 6,399,472 | 06/04/2002 | Suzuki et al. | |
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| | BE | US- 6,677,226 | 01/13/2004 | Bowen et al. | |
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| FOREIGN PATENT DOCUMENTS | | | | | | |
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| Examiner Initials* | Cite No. | Foreign Patent Document | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear | T ⁶ |
| | | Country Code ³ Number ⁴ Kind Code ⁵ (if known) | | | | |
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| Examiner Signature | <i>T. NGUYEN</i> | Date Considered | 1/12/06 |
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| Sheet 3 | of 3 | Attorney Docket Number | P05810 |

| NON PATENT LITERATURE DOCUMENTS | | | |
|---------------------------------|-----------------------|---|----------------|
| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
| TN | CA | Simon S. Cohen et al., "Laser-Induced Melting of Thin Conducting Films: Part I-The Adiabatic Approximation", IEEE Transactions on Electron Devices, Vol. 38, No. 9, September 1991, Pp. 2042-2050. | |
| | CB | Joseph B. Bernstein et al., "Laser Energy Limitation for Buried Metal Cuts" IEEE Electron Device Letters, Vol. 19, No 1, January 1998, Pp. 4-6. | |
| | CC | Simon S. Cohen et al., "Laser-Induced Melting of Thin Conducting Films: Part II-Heat-Dissipating Substrates", IEEE Transactions on Electron Devices, Vol. 38, No. 9, September 1991, Pp. 2051-2057. | |
| | CD | Will R. Moore, "A Review of Fault-Tolerant Techniques for the Enhancement of Integrated Circuit Yield", Proceedings of the IEEE, Vol. 74, No. 5, May 1986, Pp. 684-698. | |
| | CE | Yunlong Sun et al., "Optimization of Memory Redundancy Laser Link Processing", SPIE Vol. 2636, Pp. 152-164. | |
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| | CG | Ronald P. Cenker et al., "A Fault-Tolerant 64K Dynamic Random-Access Memory", IEEE Transactions on Electron Devices, Vol. ED-26, No. 6, June 1979, Pp. 853-860. | |
| | CH | A. S. Tenney et al., "Etch Rates of Doped Oxides in Solutions of Buffered HF", J. Electrochem Soc.: Solid-State Science and Technology, August 1973, Pp. 1091-1095. | |
| ↓ | CI | Gang Yang, "Laser Energy Window Simulation for Metal Cut Structure" Thesis for the Degree of Master of Science, University of Maryland, 1999, 104 pages. | |
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| Examiner Signature | T. NGUYEN | Date Considered | 1/12/06 |
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